



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Yamazaki, et al. Art Unit : 2813
Serial No. : 09/898,986 Examiner : Laura Schillinger
Filed : July 3, 2001
Title : SEMICONDUCTOR DEVICE AND METHOD OF MANUFACTURING THE
SAME

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Applicant submits the references listed on the attached form PTO-1449.

I, the undersigned, hereby certify that each item of information contained in this statement was cited in a communication from a foreign patent office in a counterpart foreign application, the communication being dated May 19, 2004, which is not more than three months prior to the filing of this statement.

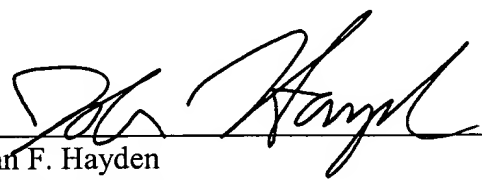
This application is currently abandoned, and a petition to revive has been filed. Also, while a final office action has been received in this matter, the Examiner agreed to withdraw the finality of the office action. Accordingly, applicant believes that this information disclosure statement is proper, and that no fee is due. In the event that any fee is due, please apply any charges or credits to Deposit Account No. 06-1050.

Respectfully submitted,

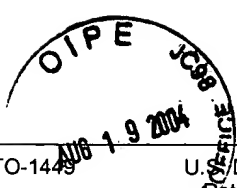
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| Substitute Form PTO-1449 (Modified) Information Disclosure Statement by Applicant (Use several sheets if necessary) (37 CFR §1.98(b)) | U.S. Department of Commerce Patent and Trademark Office | Attorney's Docket No. 07977-163003 | Application No. 09/898,986 |
| | | Applicant Yamazaki, et al. | |
| | Filing Date July 3, 2001 | Group Art Unit 2813 | |

| U.S. Patent Documents | | | | | | | |
|-----------------------|-----------|-----------------|------------------|----------|-------|----------|----------------------------|
| Examiner Initial | Desig. ID | Document Number | Publication Date | Patentee | Class | Subclass | Filing Date If Appropriate |
| | AA | | | | | | |
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| Foreign Patent Documents or Published Foreign Patent Applications | | | | | | | | |
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| Examiner Initial | Desig. ID | Document Number | Publication Date | Country or Patent Office | Class | Subclass | Translation | |
| | | | | | | | Yes | No |
| | AL | JP06-029476 | 04 FEB 1994 | JAPAN | | | Abstract | |
| | AM | JP07-111331 | 25 APR 1995 | JAPAN | | | Abstract | |
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| Other Documents (include Author, Title, Date, and Place of Publication) | | |
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| Examiner Initial | Desig. ID | Document |
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| Examiner Signature | Date Considered |
| EXAMINER: Initials citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. | |